



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al  
 Serial No. : 08/690,747  
 Filed : August 1, 1996  
 Title : METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : 1765  
 Examiner : Robert Kunemund

Commissioner for Patents  
 Washington, D.C. 20231

RECEIVED  
 MAR 01 2001  
 TC 1700

PETITION FOR TWO-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated September 22, 2000, be extended for two months to and including February 22, 2001.

Enclosed is a check for \$390 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/21/01

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

February 21, 2001  
 Date of Deposit

Veronica Whalen  
 Signature

Veronica Whalen  
 Typed or Printed Name of Person Signing Certificate

FILED 2/21/01 08690747

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